



**7510-13**

## **NATIONAL AERONAUTICS AND SPACE ADMINISTRATION**

Notice (16-020)

Notice of Intent to Grant a Partially Exclusive License

**AGENCY:** National Aeronautics and Space Administration

**ACTION:** Notice of Intent to Grant Partially Exclusive License

**SUMMARY:** This notice is issued in accordance with 35 U.S.C. 209(e) and 37 C.F.R. 404.7(a)(1)(i). NASA hereby gives notice of its intent to grant a partially exclusive license in the United States to practice the invention described and claimed in U.S. Patent No. 7,168,935 B2 titled “Solid Freeform Fabrication Apparatus and Methods,” NASA Case No. MSC-23518-1; U.S. Patent No. 8,344,281 B2 titled “Use of Beam Deflection to Control an Electron Beam Wire Deposition Process,” NASA Case No. LAR-17245-1; U.S. Patent No. 8,452,073 B2 titled “Closed-Loop Process Control for Electron Beam Freeform Fabrication and Deposition Processes,” NASA Case No. LAR-17766-1, to COSM Advanced Manufacturing Systems LLC, having its principal place of business in Peabody, Massachusetts. The fields of use may be limited to, but not necessarily limited to, aerospace. The patent rights in these inventions have been assigned to the United States of America as represented by the Administrator of the National Aeronautics and Space Administration. The prospective partially exclusive license will comply with the terms and conditions of 35 U.S.C. 209 and 37 CFR 404.7.

**DATES:** The prospective partially exclusive license may be granted unless, within fifteen (15) days from the date of this published notice, NASA receives written objections

including evidence and argument that establish that the grant of the license would not be consistent with the requirements of 35 U.S.C. 209 and 37 CFR. 404.7. Competing applications completed and received by NASA within fifteen (15) days of the date of this published notice will also be treated as objections to the grant of the contemplated partially exclusive license.

Objections submitted in response to this notice will not be made available to the public for inspection and, to the extent permitted by law, will not be released under the Freedom of Information Act, 5 U.S.C. 552.

**ADDRESSES:** Objections relating to the prospective license may be submitted to Patent Counsel, Office of Chief Counsel, MS 30, NASA Langley Research Center, Hampton, VA 23681; (757) 864-3230 (phone), (757) 864-9190 (fax).

**FOR FURTHER INFORMATION CONTACT:** Jennifer L. Riley, Patent Attorney, Office of Chief Counsel, MS 30, NASA Langley Research Center, Hampton, VA 23681; (757) 864-5057; Fax: (757) 864-9190. Information about other NASA inventions available for licensing can be found online at <http://technology.nasa.gov>.

Mark P. Dvorscak  
Agency Counsel for Intellectual Property

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